

ANDOR an Oxford Instruments company

Photovoltaics

iKon M - Features

- Electroluminescence imaging with 0.2 s integration time
- Optimal NIR sensitivity:
 - 88% QE @ 900 nm
 - 46% QE @ 1000 nm
- Fast 3 MHz and 5 MHz clocking modes
- Dual exposure ring mode
- Back-illuminated, deep depletion CCD with Fringe Suppression Technology™
- High dynamic range (80 dB)
- Lockable USB connectors
- Deep thermoelectric cooling

Zyla sCMOS - Features

- 1.2 e⁻ read noise
- 5.5 Megapixel, 6.5 µm pixel size
- High dynamic range (88 dB)
- Compact and light
- Rolling and Global shutter
- NIR optimized QE

Software Development Kit

The SDK is a dynamic link library which can be used with a wide variety of programming environments, including: C, C++, C#, Visual Basic, LabVIEW, Matlab and the HALCON image processing library. The library is available in both 32-bit and 64-bit libraries compatible with Windows (7, 8, 8.1 and 10) and Linux.



iKon-M PV Inspector Cameras for cell inspection

The ultimate high-performance CCD camera for electro- and photoluminescence imaging of photovoltaic (PV) cells and modules, combining ultra low noise electronics and optimal sensitivity in the NIR. Featuring Fringe Suppression Technology[™], this back-illuminated deep depleted sensor is specifically designed to offer ultimate performance for NIR applications, whilst minimizing etaloning. Ideally suited for very fast running PV inspection systems as found in Stringers and Cell Sorters.

Zyla 5.5 sCMOS For speed and sensitivity

Andor's Zyla sCMOS camera offers high resolution, high speed, high sensitivity imaging performance in a remarkably light and compact, TE cooled design. The 5.5 Megapixel sensor can be read out at 30 fps with only 1.2 electron read noise floor, combined with a high dynamic range of 88 dB. Zyla is suited to Cell inspection and to Module inspection in Laminators and Flashers.



Photovoltaics

Comparitive Specification Overview

| Camera | iKon-M PV Inspector | Zyla |
|---|--------------------------------|---------------------------------|
| Sensor Type | Back-illuminatedDeep Depletion | Scientific CMOS |
| Resolution | 1024 x 1024 | 2560 x 2160 |
| Pixel size (µm) | 13 x 13 | 6.5 x 6.5 |
| QE @ 900 nm / 1000 nm | 88% / 46% | 15% / 4% |
| Read Noise | 2.5 e ⁻ | 1.2 e ⁻ |
| Dynamic Range | 80 dB | 88 dB |
| Frame Rate (fps) | 2.6 (4.2) | 100 |
| Typical T measurement (Exposure/total cycle) | 0.2s / 0.6s (0.45s) | 0.5/0.6s |
| Typical Use for PV Inspection | Stringer, Cell Sorter | Laminator, Flasher, Cell Sorter |
| Data Interface | USB 2.0 | Camera Link |

Quantum Efficiency Curves



*QE is a measurement for sensor sensitivity. It gives the probability that a photon hitting the sensor will set an electron free.

Andor, the Andor logo and Product Name are trademarks of Andor Technology Ltd. All other marks are property of their owners. Changes are periodically made to the product and specifications are subject to change without notice.



Head Office

7 Millennium Way Springvale Business Park Belfast BT12 7AL Northern Ireland Tel: +44 (0)28 9023 7126 Fax: +44 (0)28 9031 0792

North America

300 Baker Avenue Suite 150 Concord, MA 01742 USA Tel: +1 860-290-9211 Fax: +1 860-290-9566

Japan

5F IS Building 3-32-42 Higashi-Shinagawa Tokyo 140-0002 Japan Tel: +81-(0)3-6732-8968 Fax: +81-(0)3-6732-8939

China

Unit 1, Building A, No. 66 Zhufang Road, Haidian District, Beijing 100085 P. R. China Tel: +86 (0)10-8271-9066 Fax: +86 (0)10-8271-9055

Find us on





The Business of Science®

OEMPVF 0617